



MICRON.092CP1

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Stephen L. Willis  
Appl. No. : 09/552,383  
Filed : April 19, 2000  
For : CHEMICAL MECHANICAL  
PLANARIZATION OF  
CONDUCTIVE MATERIAL  
Examiner : Jose R. Diaz  
Group Art Unit : 2815

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

April 18, 2005  
(Date)

Michael H. Trachholm, Reg. No. 37,743

**RESPONSE TO OFFICE ACTION FILED WITH A REQUEST FOR CONTINUED  
EXAMINATION**

**Mail Stop AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed October 20, 2004, please amend the above-captioned application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.